JUN 2 9 2005 W

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BADApplicant(s): Goshi Biwa et al.

Appl. No.:

10/786,667

Conf. No.:

2982

Filed:

February 25, 2004

Title:

METHOD OF FABRICATING SEMICONDUCTOR DEVICE AND

SEMICONDUCTOR DEVICE

Art Unit:

2822

Examiner:

M. Prenty

Docket No.:

112857-476

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

CERTIFICATE OF MAILING BY EXPRESS MAIL UNDER 37 CFR 1.10

Sir:

I hereby certify that the following documents relating to the above-identified application:

- 1. Transmittal Letter (1 page in duplicate);
- 2. Response to Office Action (2 pages);
- 3. A copy of the date stamped postcard that indicates receipt by the Patent Office of the foreign priority document (1 page); and
- 4. Return Receipt Postcard.

are being deposited with the United States Postal Service with sufficient postage as Express Mail in an envelope addressed to:

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

on June 29, 2005.

Respectfully submitted,

BELL, BOYD & LLOYD LLC

Heather Foster

Name of Person Mailing Correspondence

Signature

EV 512 724 844 US

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In re Patent Application of: Biwa et al.

Docket No. 0112857-347 - USSN 10/211,419

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Response to Notice to file missing parts in duplicate, notice of file missing parts, executed declaration and power of attorney, late fee \$130.00, certified copy of Japanese 2001-237087, Information Disclosure Statement, PTO 1449, references, postcard O P E

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JUN 2 9 2005

TRANSMITTAL LETTER (General - Patent Pending)

Docket No. 0112857-476

In Recapplication Of: Goshi Biwa et al.

Application No. 10/786,667

Filing Date February 25, 2004 Examiner

Customer No.

Group Art Unit

Confirmation No.

M. Prenty

29175

2822

2982

Title: METHOD OF FABRICATING SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE

COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Response to Office Action (2 pages); A copy of the date stamped postcard that indicates receipt by the Patent Office of the foreign priority document (1 page); Certificate of Express Mail EV 512 724 844 US (1 page); and return receipt postcard

in the above identified application.

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Credit any overpayment.

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Dated: June 29, 2005

Thomas C. Basso Reg. No. 46,541 P.O. Box 1135

Chicago, Illinois 60690-1135

Phone: (312) 807-4310

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0112857-476

Mail Stop Amendment Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

This Response is submitted in response to the Notice of Allowance dated May 26, 2005 and Patent Office Communication dated June 8, 2005.